

Docket No.: YOR920030059US1
(20140-00302-US)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Panayotis C. Andricacos et al.

Application No.: 10/615,794

Confirmation No.: 3511

Filed: July 10, 2003

Art Unit: 1742

For: A VOID-FREE DAMASCENE COPPER
DEPOSITION PROCESS AND MEANS OF
MONITORING THEREOF

Examiner: King, Roy V.

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AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

The present Amendment and Remarks are submitted in response to the final Office
Action dated February 8, 2006.

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks/Arguments begin on page 5 of this paper.